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**Complete if Known**

Application Number

Filing Date

First Named Inventor

**Art Unit**

**Examiner Name**

Attorney Docket Number

12091

Sheet	1	of	2
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## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>2</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
		WO99/10688 A1	03-04-1999	Edelson		
		WO 99/13562 A1	03-18-1999	Tavkhelidze et		

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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PTO/SB/08B (08-03)

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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**Complete if Known**

Application Number		10/534633
Filing Date		05/10/2005
First Named Inventor		Avto TAVKHELIDZE
Art Unit		2826
Examiner Name		Benjamin T Liu
Attorney Docket Number		12091

Sheet 2 of 2

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
/BTL/		TAVKHELIDZE et al., "Electron tunneling through large area vacuum gap", Thermoelectrics, 2002. Proceedings ICT '02., 08-25-2002, pp435-438, Piscataway, NJ, USA	
/BTL/		HISHINUMA et al., "Refrigeration by combined tunneling and thermionic emission in vacuum: Use of nanometer scale design", Appl Phys Lett, 04-23-2001, pp2572-2574, vol 78, no 1	

Examiner Signature	/Benjamin T Liu/	Date Considered	10/10/2007
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